

# Supporting Information

## **A Flexible and Highly Sensitive Pressure Sensor Based on Microdome-Patterned PDMS Forming with Assistance of Colloid Self-Assembly and Replica Technique for Wearable Electronics**

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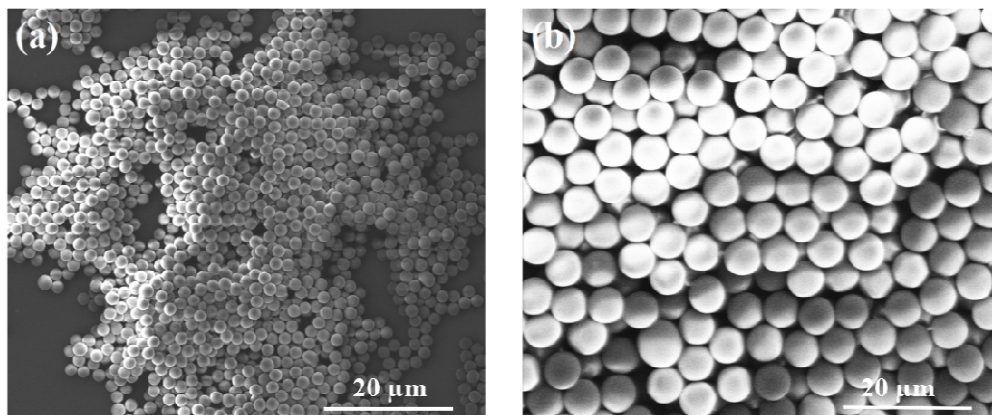
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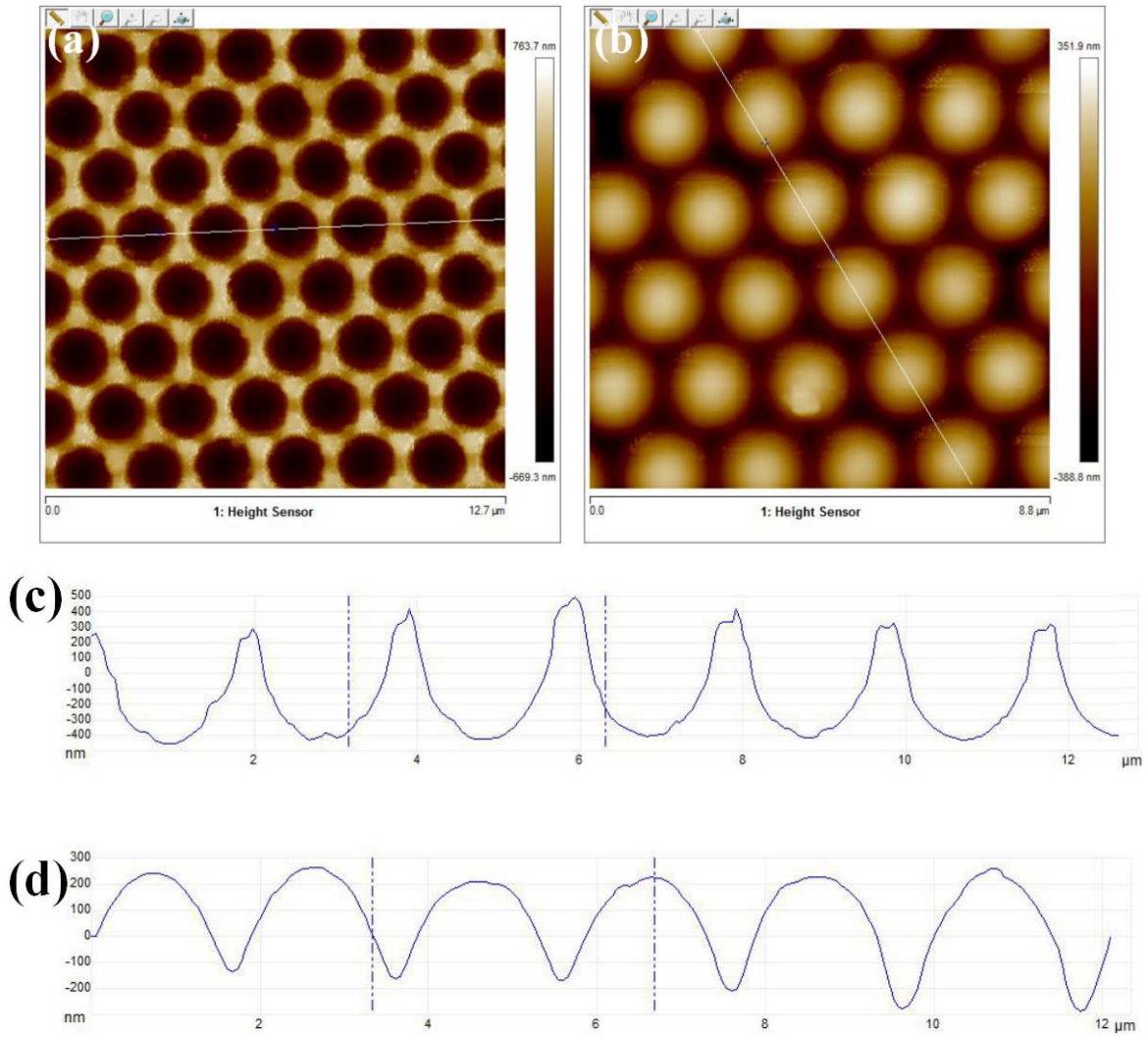
<sup>||</sup>These authors contributed equally to this work.



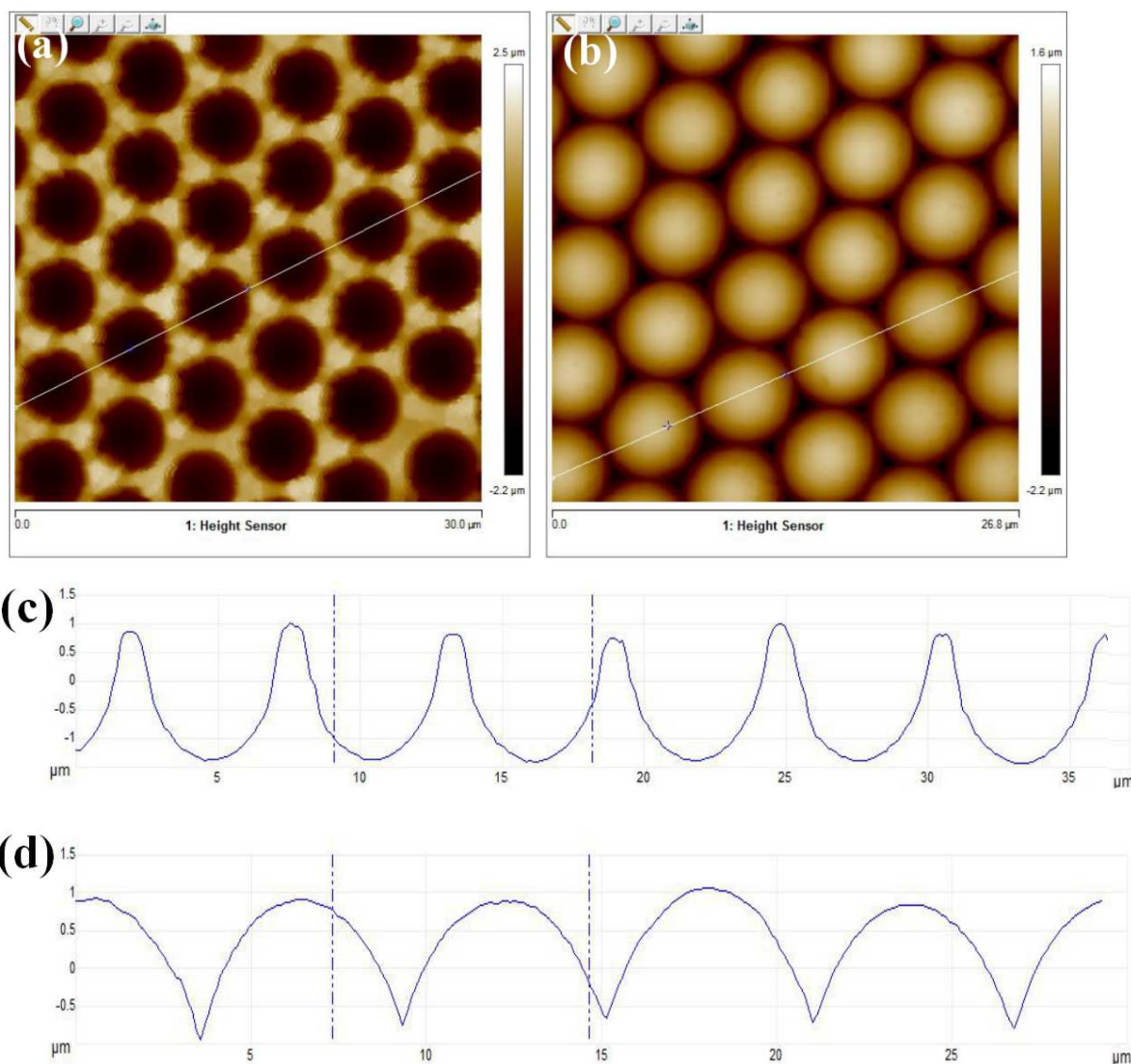
**Figure S1.** (a) SEM image of PS beads with 2  $\mu\text{m}$  diameter. (b) SEM image of PS beads with 5.6  $\mu\text{m}$  diameter.



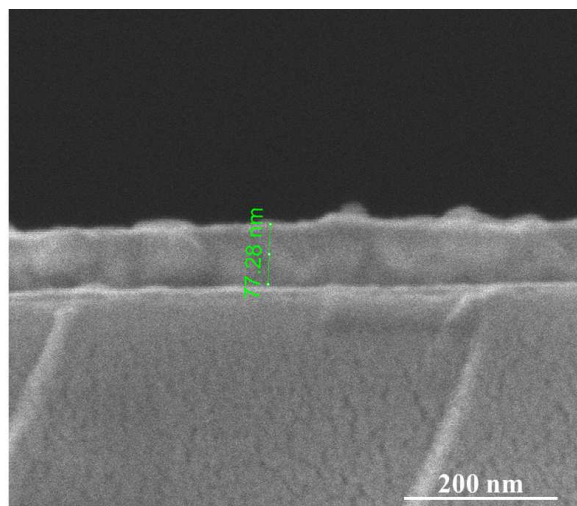
**Figure S2.** The photograph of the concave PDMS film, showing the optical characteristics.



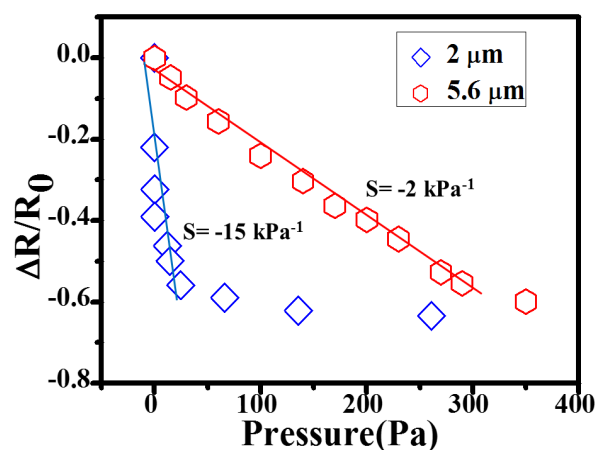
**Figure S3.** (a) The 2D SPM image at the bottom of the concave PDMS film based on 2  $\mu\text{m}$ -PS microspheres. (b) The 2D SPM image at the top of the microdome PDMS film based on 2  $\mu\text{m}$ -PS microspheres. (c) The 2D line profile at the bottom of the concave PDMS film based on 2  $\mu\text{m}$ -PS microspheres. (d) The 2D line profile at the top of the microdome PDMS film based on 2  $\mu\text{m}$ -PS microspheres.



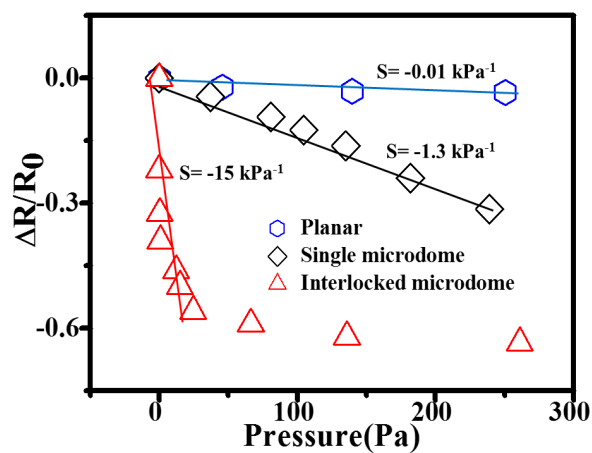
**Figure S4.** (a) The 2D SPM image at the bottom of the concave PDMS film based on 5.6  $\mu\text{m}$ -PS microspheres. (b) The 2D SPM image at the top of the microdome PDMS film based on 5.6  $\mu\text{m}$ -PS microspheres. (c) The 2D line profile at the bottom of the concave PDMS film based on 5.6  $\mu\text{m}$ -PS microspheres. (d) The 2D line profile at the top of the microdome PDMS film based on 5.6  $\mu\text{m}$ -PS microspheres.



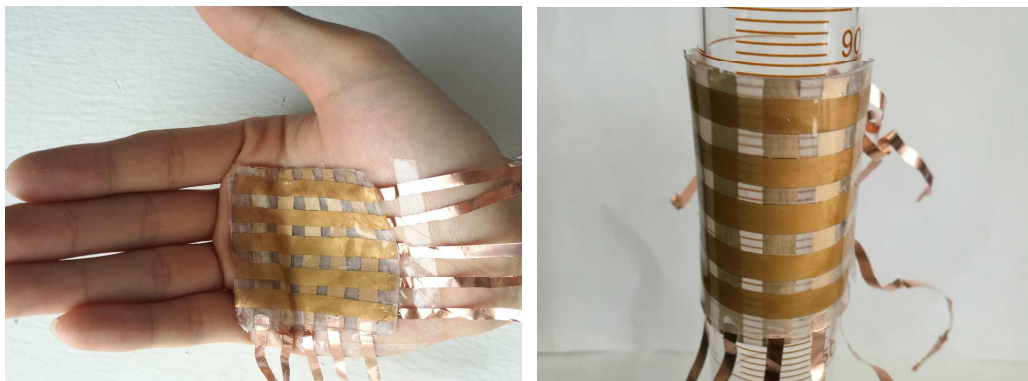
**Figure S5.** Cross-sectional SEM image of gold layer sputtered on PDMS surface.



**Figure S6.** Sensitivity of different pressure sensors based on 2 μm and 5.6 μm sized PS sphere in low-range pressure.



**Figure S7.** Sensitivity of different pressure sensors based on the planar film, single microdome film, and the interlocked microdome film in low-range pressure.



**Figure S8.** Photographs of the flexible pressure sensor array attached on human palm and graduated cylinder.